



#19/42103

NIT-215

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

S. KONDO et al

Serial No. 09/637,570 Group Art Unit: 2812

Filed: August 14, 2000 Examiner: Ha T. Nguyen

For: POLISHING METHOD, METALLIZATION FABRICATION
METHOD, METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICE AND SEMICONDUCTOR DEVICEPETITION FOR EXTENSION OF TIMECommissioner for Patents
Washington, D.C. 20231

TC 2800 MAIL ROOM

APR 17 2003

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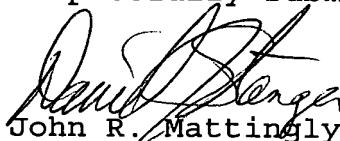
Sir:

It is respectfully requested that a second-month Extension of Time, to and including April 15, 2003, be granted in which to respond to the Office Action dated November 15, 2002 in the above-identified application. An Amendment and Petition for One Month Extension of Time were filed on March 17, 2003.

Our check including the amount of \$300.00 is attached in payment of the appropriate fee.

The Commissioner is hereby authorized to charge any additional payment due, or to credit any overpayment, to Deposit Account No. 50-1417.

Respectfully submitted,


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Date: March 17, 2003